

Electronic Acknowledgement Receipt

EFS ID:	1635892
Application Number:	10690507
International Application Number:	
Confirmation Number:	6043
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing
First Named Inventor/Applicant Name:	Ji Yong Park
Customer Number:	49455
Filer:	Hung H. Bui/Karen Jones
Filer Authorized By:	Hung H. Bui
Attorney Docket Number:	1514.1032
Receipt Date:	29-MAR-2007
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Application Type:	Utility

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Submitted with Payment	yes
Payment was successfully received in RAM	\$ 1240
RAM confirmation Number	2181
Deposit Account	

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
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1	Request for Continued Examination (RCE)	FiledRCE03292007.pdf	263409	no	2
Warnings:					
This is not a USPTO supplied RCE SB30 form.					
Information:					
2	Fee Worksheet (PTO-06)	fee-info.pdf	8372	no	2
Warnings:					
Information:					
Total Files Size (in bytes):			271781		
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